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| L Number | Hits | Search Text | DB | Time stamp |
|----------|------|--|---|------------------|
| - | 21 | "3943462" | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2002/08/30 15:08 |
| - | 0 | (semiconductor adj laser) and facet and (anti\$reflection adj coating) and (thickness adj3 quarter) and sion\$h and pcvd and (optical adj index) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2002/08/30 15:17 |
| - | 0 | (semiconductor adj laser) and facet and (antireflection adj coating) and (thickness adj3 quarter) and sion\$h and pcvd and (optical adj index) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2002/08/30 15:15 |
| - | 0 | (semiconductor adj laser) and facet and (reflection adj coating) and (thickness adj3 quarter) and sion\$h and pcvd and (optical adj index) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2002/08/30 15:16 |
| - | 0 | (semiconductor adj laser) and facet and (reflection adj coating) and (thickness adj3 quarter) and pcvd and (optical adj index) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2002/08/30 15:16 |
| - | 0 | (semiconductor adj laser) and facet and (reflection adj coating) and (thickness adj3 quarter) and pcvd | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2002/08/30 15:16 |
| - | 0 | laser and facet and (anti\$reflection adj coating) and (thickness adj3 quarter) and sion\$h and pcvd and (optical adj index) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2002/08/30 15:17 |
| - | 6 | (semiconductor adj laser) and facet and (reflection adj coating) and (thickness adj3 quarter) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2002/08/30 15:29 |
| - | 0 | (semiconductor adj laser) and (reflection adj coating) and ((pcvd) or (plasma adj enhanced)) and sixoynhy | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2002/08/30 15:30 |
| - | 0 | (semiconductor adj laser) and (reflection adj coating) and ((pcvd) or (plasma adj enhanced)) and sixoyny | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2002/08/30 15:30 |
| - | 0 | (semiconductor adj laser) and (reflection adj coating) and ((pcvd) or (plasma adj enhanced)) and sion | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2002/08/30 15:31 |
| - | 13 | (semiconductor adj laser) and (reflection adj coating) and ((pcvd) or (plasma adj enhanced)) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2002/08/30 16:28 |
| - | 0 | (semiconductor adj laser) and (reflection adj coating) and ((pcvd) or (plasma adj enhanced)) and (optical adj index) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2002/08/30 15:32 |
| - | 4 | silicon near3 oxide near nitride near3 hydrogen and reflection and coating | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2002/09/01 11:47 |

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|--|-----|--|---|------------------|
| | 116 | (semiconductor adj laser) and coating and (reflectiv\$3 adj3 index) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2002/09/01 11:49 |
| | 1 | (semiconductor adj laser) and coating and (reflectiv\$3 adj3 index) and 1.83 | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2002/09/01 11:52 |
| | 8 | (semiconductor adj laser) and coating and (reflectiv\$3 adj3 index) and (standing adj wave) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2002/09/01 12:25 |
| | 114 | (semiconductor adj laser) and (coating adj3 index) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2002/09/01 13:20 |
| | 65 | (semiconductor adj laser) and (reflection adj coating) and (quarter adj wavelength) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2002/09/01 13:22 |
| | 34 | (semiconductor adj laser) and (reflection adj coating) and (quarter adj wavelength) and gaas | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2002/09/01 13:22 |

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